Invited review article: high-speed flexure-guided nanopositioning: mechanical design and control issues

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#	Paper	IF	Citations
375	High speed atomic force microscopy enabled by a sample profile estimator. **2013**, 102, 213118		14
374	Development of a novel sort of exponent-sine-shaped flexure hinges. *Review of Scientific Instruments*, **2013**, 84, 095008	1.7	28
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